## **CLAIMS**

## What is claimed is:

- 2. The heat sink of claim 1, wherein at least a portion of said heat transfer element comprises a plurality of superimposed, contiguous, mutually adhered layers of thermally conductive material.
- 3. The heat sink of claim 2, wherein said thermally conductive material comprises a metal.
- 4. The heat sink of claim 3, wherein said metal comprises copper, aluminum, tungsten, or titanium.
- 5. The heat sink of claim 2, wherein said thermally conductive material comprises a ceramic or a glass.
- 6. The heat sink of claim 1, wherein said heat transfer element comprises a plurality of particles that are secured to one another.
- 7. The heat sink of claim 6, wherein adjacent ones of said particles are sintered together.
- 8. The heat sink of claim 6, wherein adjacent ones of said particles are secured together with a binder.

- 9. The heat sink of claim 2, wherein at least some of said plurality of superimposed, contiguous, mutually adhered layers comprise sheets of said thermally conductive material.
- 10. The heat sink of claim 9, wherein adjacent sheets are secured together with an adhesive material.
  - 11. The heat sink of claim 9, wherein adjacent sheets are thermally bonded together.
- 12. The heat sink of claim 1, wherein said at least one non-linear passageway is configured to permit airflow therethrough.
- 13. The heat sink of claim 1, further comprising a heat dissipation element adjacent to said heat transfer element and extending to a location remote from the semiconductor device.
- 14. The heat sink of claim 13, wherein at least a portion of said heat dissipation element comprises a plurality of superimposed, contiguous, mutually adhered layers of thermally conductive material.
- 15. The heat sink of claim 14, wherein said heat dissipation element includes a plurality of fins.